

Notice of References Cited	Application/Control No. 10/645,878		Applicant(s)/Patent Under Reexamination FUJII ET AL.	
	Examiner Shih-Chao Chen		Art Unit 2821	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,496,138	12-2002	Honma, Shinichi	342/70
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NON-PATENT DOCUMENTS

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